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Docket No. 103-1009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Seung Jun LEE et al.

Application	11/050,752	Group Art Unit:	2125
Filed:	February 7, 2005	Examiner	Zoila E. Cabrera
Customer No.:	38209	Confirmation No.	7187
For:	SYSTEM TO AND METHOD OF MONITORING CONDITION OF PROCESS TOOL		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

*OK to Enter
CB 12/24/06*

Sir:

In response to the Office Action mailed July 26, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.